



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **KIRA, et al.**

Group Art Unit: **2827**

Serial No.: **08/897,953**

Examiner: **David E. GRAYBILL**

Filed: **July 24, 1997**

**P.T.O. Confirmation No.: 5157**

For. **METHOD AND SYSTEM FOR FABRICATING A SEMICONDUCTOR DEVICE**

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: August 31, 2005

Sir:

This Preliminary Amendment is being filed with a Request for Continued Examination for the above-captioned patent application. Please amend the above-captioned patent application as follows: